In re Application of:

Docket No. 03500.010530.5

Kiyofumi Sakaguchi, et al.

Examiner: George R. Fourson, III

Appln. No.: 10/085,046

Group Art Unit: 2823

Filed: March 1, 2002 Confirmation No.: 7805

For: PROCESS FOR PRODUCTION

OF SEMICONDUCTOR

SUBSTRATE June 16, 2008 (Monday)

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and Statement of Substance of Interviews in the above-identified application.

X No additional claims fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	9	MINUS	96	= 0	x \$25 \$50	\$ 0.00	
INDEP. CLAIMS	9	MINUS	33	= 0	x \$200 \$100	\$ 0.00	
Fee for Multiple Dependent claims \$180/\$360							
	\$ 0.00						

TOTAL ADDITIONAL FEE FOR THIS AMENDMENT	\$ 0.00
Verified Statement claiming small entity status is enclosed, if not filed previously.	
A check in the amount of \$ is enclosed.	

	Please charge \$	to Deposit Account No. 06-12	205. A duplicate of this sheet is enclosed.
X	06-1205 is hereby revoked. under 37 C.F.R. §§ 1.16 and	The Commissioner is hereby 1.17 which may be required do	er 37 C.F.R. § 1.18 to Deposit Account No. authorized to charge any additional fees uring the entire pendency of this application, 205. A duplicate of this paper is enclosed.
	Please charge the amount of to Deposit Account No. 06-1		ension fee for response within <u>two</u> months
	A check in the amount of \$_	to cover the Informat	ion Disclosure Statement fee is enclosed.
X	11		ashington, D.C. office by telephone at directed to our address given below.
		Respec	ctfully submitted,

/Daniel S. Glueck/
Daniel S. Glueck
Attorney for Applicants
Registration No. 37,838

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